

Notice of References Cited		Application/Control No. 10/723,306	Applicant(s)/Patent Under Reexamination NAM ET AL.	
		Examiner Christina Johnson	Art Unit 1725	Page 1 of 1

U.S. PATENT DOCUMENTS

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Name	Classification
	A	US-5,116,586	05-1992	Baacke et al.	423/239.2
	B	US-5,427,753	06-1995	Miura et al.	423/239.2
	C	US-3,755,153	08-1973	Rosback, Donald H.	585/820
	D	US-5,279,997	01-1994	Montreuil et al.	502/62
	E	US-4,473,535	09-1984	Kittrell et al.	423/239.2
	F	US-4,962,075	10-1990	Green et al.	502/71
	G	US-4,961,917	10-1990	Byrne, John W.	423/239.2
	H	US-5,171,553	12-1992	Li et al.	423/239.2
	I	US-4,052,337	10-1977	Nishikawa et al.	502/60
	J	US-4,170,571	10-1979	Ritscher, James S.	423/718
	K	US-5,223,236	06-1993	Inoue et al.	423/213.2
	L	US-5,270,024	12-1993	Kasahara et al.	423/213.2
	M	US-4,297,328	10-1981	Ritscher et al.	423/213.2

FOREIGN PATENT DOCUMENTS

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Country	Name	Classification
	N					
	O					
	P					
	Q					
	R					
	S					
	T					

NON-PATENT DOCUMENTS

*		Include as applicable: Author, Title Date, Publisher, Edition or Volume, Pertinent Pages)
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	V	
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	X	

*A copy of this reference is not being furnished with this Office action. (See MPEP § 707.05(a).)
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